INVESTIGATION OF STRUCTURAL AND OPTICAL PROPERTIES OF POWDER TIN OXIDE (SnO_x) ANNEALED IN AIR

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Abstract. A series of composite SnO_x materials were prepared by SnO powder heating at different temperatures in air for 2 hr. It was found that SnO with its tetragonal structure could transform into the Sn phase or tetragonal SnO and tetragonal SnO_2 depending on treatment conditions. The influence of heating at different temperatures on properties of the SnO_x has been studied. The dependences of structural and optical properties of SnO_x from temperatures of annealing in air have been investigated. Correlations between the structural and optical properties of the products were found.

Keywords: SnO powder, SnO_2, temperatures, structural and optical.

1. INTRODUCTION

Tin oxide is of great technological interest as transparent conductive electrodes, IR reflecting heat mirrors, and SnO/Si solar cell devices with high conversion efficiency [1]. Moreover, SnO_2-based sensor devices have been used as a prototype for detecting reducing and inflammable gases [2]. Tin oxide thin films have been successfully demonstrated as transparent conductors (TC), optical windows for the solar spectrum, stability resistors, touch-sensitive switches, digital displays, light emitting diodes (LEDs), electrophochromic displays (ECDs), and many more [3], mainly due to their outstanding properties.

The consensus of the researchers is that for TC, high transmittance (T%) and relatively low electrical resistivity (ρ) is desirable while for applications such as display devices and LEDs, low electrical resistivity is desirable and not high transmittance [4]. These applications rely on itinerant electrons that stem from the ionization of the dopants and enter the conduction band. For ECDs, which hinges on the ability of the material to sustain mixed conduction of ions and electrons, low electrical resistivity is more desirable than high transmittance [5], additionally it is useful to have some water content in the resultant film [4], which plays key role in inducing electrochromic (EC) effect.

It is noticed from the literature survey that the variety of methods of preparation will lead to the layers having different optical and electrical properties, which evokes critical influence of oxygen vacancies, serving as donor in tin oxide films [5]. In principle physical methods viz. sputtering [3], and thermal evaporation [6], lead to weakly non-stoichiometric tin oxide with co-existence of other insulating phases like SnO, resulting into relatively high resistive films. The range of resistivity in asdeposited SnO_x films typically varies from 6.6 × 10^{-3} Ω cm to 2.5 × 10^{-3} Ω cm [3]. On the other hand chemical methods especially spray pyrolysis technique, lead to strongly non-stoichiometric tin oxide films without co-existence of insulating phases, resulting into comparatively low resistive films [7]. The electrical resistivity in asdeposited SnO_x films typically varies from 1.45 × 10^{-3} Ω cm to 0.45 × 10^{-3} Ω cm, which is several times less than the films deposited by physical methods. Therefore, it can be concluded that the SnO_x films deposited by spray pyrolysis technique are more susceptible to oxygen deficiencies [8].

We are interested in SnO_x films in connection with the electrochromism. Electrochromic tin oxide films were described recently by Orel et al. [9] and Olivi et al. [10] who prepared their samples by dip-coating and Isidorosson et al. [11] by sputtering and emphasize the importance of various properties that SnO_x should exhibit for attaining pronounced electrochromism. In this investigation, we have employed spray pyrolysis technique for SnO_x thin film deposition and discussed their structural, electrical and optical properties. The deposition has been carried out from aqueous stannic chloride solution, with a postulation that the resultant films may have some water content [11], which would be in turn beneficial for better electrochromic effect.
Several experiments on electrochromism in SnO thin films are underway and results will be disseminated elsewhere.

SnO₂ is an n-type semiconductor with an optical band gap of about 3.6 eV. SnO₂ crystallizes in the rutile structure $D_{4h}^{2}$ [12]. In rutile SnO₂, each atom is surrounded by a distorted octahedron of O atoms with all Sn distances equal to 2.05 Å. In comparison with SnO₂, the structure and physical properties of SnO have not been extensively investigated. The structure of SnO is layered, similar to that of PbO, with tetragonal structure $D_{4h}^{2}$ [12]. In this structure the Sn²⁺ is situated at the apex of a square pyramid with Sn-O distances equal to 2.224 Å and O-Sn-O angles 11.73°. Also, SnO exists in an orthorhombic phase depending on the preparation procedures. The optical band gap is in the range 2.5–3 eV.

The oxidation of tin and in particular the mechanism of the oxidation process from SnO to SnO₂ have been extensively studied using various kinds of preparation techniques [13]. In general, when tin oxide films were deposited on a high temperature substrate by several deposition techniques, since it dissociates in the gaseous SnO and forms oxygen-deficient SnO$_x$ ($x < 2$) films, post-annealing in an O₂ environment should be given. Geurts et al. [14] and Reddy et al. [13] found that the films when annealed reach the final oxidation state either through simple oxidation of SnO (direct transition) or through intermediate oxidation states (indirect transition), namely Sn$_2$O$_3$ or SnO$_2$, depending on the deposition parameters.

According to most former studies [13], the oxidation from SnO and SnO₂ was carried out without knowledge of the initial oxygen content in as-deposited films and it was reported that the perfect SnO₂ formation could only be attained after above 600° C annealing in O₂ exposure. Therefore the influences of initial composition which intimately depends on deposition parameters, on the oxidation process and crystallization from SnO and SnO₂ were not yet systematically clarified as annealing temperature is increased.

Moreover, many extensive investigations of the oxidation state of tin oxide have been carried out using Auger electron spectroscopy (AES), core-level and valence-band (VB) X-ray photoelectron spectroscopy (XPS), ion scattering spectroscopy (ISS), and ultraviolet photoelectron spectroscopy (UPS) [15], but quantitative analysis is complicated by the difficulty of preparing standard samples with an accurately known composition, and the modification of surface composition by an incident electron or ion beam.

Detailed analyses of the VB region led to the distinction between SnO and SnO₂ by UPS and VB XPS, where the presence of the prominent leading peak of a tin 5s-derived origin for SnO and that of an O 2p-derived structure at the lower binding energy side of the VB in SnO₂ uses the characteristic peak to distinguish the SnO and SnO₂ phases [16]. Recently Themlin et al. [17] and Sanjirns et al. [18] reported that a sizable chemical shift of 0.7 eV was observed between Sn$^{2+}$ (SnO) and Sn$^{4+}$ (SnO₂) by XPS. In a previous report [19], we also found that the chemical shift between Sn$^{2+}$ and Sn$^{4+}$ occurred as much as 1.0 ± 0.02 eV in XPS analyses and 2–4 ± 1 eV in AES spectra. However, the chemical shift measured from AES spectra was not reliable because main doublet Auger transitions (M₄, N₄, N₅, M₄M₄N₅, N₄N₅) in tin oxide were not well resolved.

Since, ultraviolet photoelectron spectroscopy (LIPS) experiments for surface electronic structure of tin oxide were performed only on single crystal SnO₂ (001) and SnO₂ (110) surfaces using synchrotron light and He I UV sources [20]. Cox et al. [21] found unusual band gap emission at the clean SnO₂ crystal surface after Ar⁺ bombardment and Themlin et al. [35] also reported that the tin-derived character of the band gap defect states was found in the perturbed SnO₂(110) surface by the ion bombardment.

In this present work, we thoroughly examine the oxidation processes and the variations of the structural properties of SnO that have undergone the transformation SnO to SnO₂ using SnO powder heating at different temperatures in air for 2 hr. The effect of the temperatures in the optical and structural properties of the products is discussed.

2. EXPERIMENTAL DETAILS

99.99% pure SnO powders were placed in an aluminia boat positioned at the centre of the quartz tube. The temperature in the furnace was rapidly ramped up to 250, 450, 650 and 850°C kept for 2 hr. During the process, a constant flow of air. The crystal structure of the SnO₂ were characterized by x-ray diffraction (XRD) using a DRON 4 utilizing Cu Ka radiation. UV/visible absorption measurements were carried out on the SnO₂ using a spectrophotometer (UV-210A, Shimadzu) in a range between 90 and 900 nm. The IR studies were carried out using FIR -spectrometer Vertex 70 (Bruker) at room temperature

3. RESULTS AND DISCUSSION

3.1. X-ray diffraction studies

Crystal structure and phase of the powder samples were determined from the XRD patterns. Fig. 1 shows...
X-ray diffraction (XRD) patterns of the SnO powder heating at different temperatures (250, 450, 650 and 850° C) for 2 hr in air and SnO₂ powder. All the peaks in Fig. 1(a and b) can be readily indexed as tetragonal SnO with cell parameters $a = 3.80 \text{ Å}$ and $c = 4.84 \text{ Å}$, in good agreement with the values from the standard card (JCPDS, no. 06-0395). The XRD spectrum from the SnO powder heating at 450° C (Fig. 1c) shows a very strong feature of texture structure. When comparing this spectrum with the XRD spectrum acquired from standard tetragonal SnO powders fig. 1a, the stronger peaks shown in Figure 1c are indexed to be (200), (110), (102), (211), (301), (400) for Sn, (101), (110), (002), (200), (112), (211), (103), (220), (004) for SnO and (110), (101), (200), (211), (220), (002), (310), (112), (301), (202), and (312) planes for SnO₂. Therefore, Sn, SnO and SnO₂ are simultaneously present at the annealing temperature of 450° C, and the intergrowth mechanisms may occur at this thermal oxidizing temperature [22].

When the annealing temperature further increases to 650° C, we can observe the disappearance of these Sn and SnO diffraction peaks, demonstrating that complete SnO₂ powders have been formed with a tetragonal rutile structure. The thermal oxidation process of SnO into SnO₂ may be described as follows [23]: due to the existence of environmental oxygen, the oxidation begins at the surface of the Sn particles, and SnO and SnO₂ phases are nucleated and formed as dispersed clusters on the surface of the Sn particles. The SnO₂ clusters keep on growing into nanoparticles when the temperature is high enough to allow oxygen to diffuse into the SnO particles. Fig. 1(d, e and f) represent only the characteristic SnO₂ peaks corresponding to (110), (101), (200), (111), (210), (211), (220), (002), (310), (112), (301), (202) and (312) planes and the SnO powder is believed to be perfectly oxidized into SnO₂. As increases of the temperatures from 650 to 850° C, no changes in position and intensity of the XRD peaks were found compared with this temperature.

From this observation it was proved that an annealing temperature 450° C was not high enough completely to form the highest oxidation state SnO₂. It was reported in [24] that the annealed of polycrystalline SnO could completely reach pure polycrystalline SnO₂ after post-annealing at temperatures higher than 600° C in an O₂ atmosphere. In consequence, the oxidation from SnO to SnO₂ intimately depends on the initial content of oxygen and the annealing temperature.

### 3.2. Optical properties for SnO

It is well known that SnO₂ is a degenerate semiconductor with band gap energy ($E_g$) in the range of 3.4—4.6 eV [25]. This scatter in band gap energy ($E_g$) of SnO₂ may be due to varied extent of non-stoichiomial-
etry of the deposited layers. The dependency of the band gap energy on the carrier concentration has been explicitly given in the literature [25]. It has been apprehended that band gap energy increases linearly with the increase in carrier concentration to the power 2/3.

Fig. 2(a and b) shows the reflectance and the variation of \((a\nu)^2\) versus \(\nu\) for SnO powder annealing at different temperatures (450, 550, 650 and 850\(^\circ\)C) and SnO\(_2\) powder. The nature of the plots indicates the existence of direct optical transitions. The band gap \((E_g)\) is determined by extrapolating the straight-line portion of the plot to the energy axis. The intercept on energy axis gives the value of band gap energy \(E_g\) for all the samples and the values lie in the range of 3.58—3.73 eV. It is noticed that band gap energy value is minimum (3.58 eV) for samples SnO annealed at 450\(^\circ\)C and annealed at 550 and 650\(^\circ\)C, amongst all other samples, owing to lower carrier concentration. It increases gradually and attains maximum (3.72 eV) for samples annealed at 850\(^\circ\)C and SnO\(_2\), carrier concentration being higher for these samples. As carrier concentration is higher, absorption of the light by the carriers also increase, leading to higher absorption coefficient \((a)\) in the samples annealed at 850\(^\circ\)C and SnO\(_2\).

The constituents of valance and conduction band in SnO\(_x\) have been described by Munnix and Schmeits [26]. The width of the valance band is about 9 eV, which has been segmented in three different regions resulting from, (i) coupling of Sn \(s\) orbitals and O \(p\) orbitals, (ii) mingling of O \(p\) orbitals with smaller fraction of Sn \(p\) orbitals and (iii) mainly O \(p\) lone pair orbitals. The Sn \(s\) states mainly contribute to the formation of bottom of conduction band and top of conduction band has dominated Sn \(p\) character. The above discussion is clear enough to understand \(s \rightarrow p\) direct optical transition in SnO\(_2\).

### 3.3. IR studies on SnO\(_x\)

The IR transmittance spectra of the SnO powder heating at different temperatures (250, 450, 650 and 850\(^\circ\)C) for 2 hr in air and SnO\(_2\) powder in the low frequency range 550—800 cm\(^{-1}\) are shown in Fig. 3. Several bands due to fundamentals, overtones and
combinations of OH, Sn–O and Sn–O–Sn entities appear in the 4000—800 cm\(^{-1}\) range; below 800 cm\(^{-1}\) there occurs the cut-off arising from lattice vibrations.

The results and the proposed attributions are presented in Table 1 and compared with the data published in the literatures [27—31]. The discrepancies concerning these attributions are due to several factors: (i) the nature of the sample (monocrystal, powder, colloidal suspension) and the proportion of low-coordination sites [32]; (ii) the stoichiometry of the oxide, i.e. the presence of intrinsic defects; (iii) the presence of impurities, i.e. extrinsic defects; (iv) the size and shape of the particles [33]; (v) the hydroxyl groups concentration.

### 4. CONCLUSIONS

In conclusion, the oxidation from SnO to SnO\(_2\) strongly depended on the preparation method, the initial oxygen content, and the annealing temperature, it started with internal disproportionation and was evolved through direct/indirect transformation. During the indirect phase transformation, intermediate phases were involved and the distorted -o-SnO phase was also observed. On the other hand, in the case of direct transformation, when SnO comprised a tin matrix similar to the SnO\(_2\) plane it can be easily transformed into SnO\(_2\) with preferred orientation along the axis similar in the atomic distance of the tin matrix.

**Table 1.** IR band positions and assignments for SnO powder annealing in air at different temperatures (250, 450, 650 and 850° C) for 2h and SnO\(_2\) powder

<table>
<thead>
<tr>
<th>(\nu) (cm(^{-1}))</th>
<th>Reference</th>
<th>Fundamental Vibrations(a)</th>
</tr>
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<tr>
<td>540 [30]; 555.7; 558.1; 559.5; 561 [31]; 562.2; 564; 565.3; 569.7; 574.9; 579.7; 580.1; 586.8; 596.2; 599.6; 601.1; 604.1; 605.5</td>
<td>[30, 31], this work(^*)</td>
<td>(\nu) (Sn–O, T)</td>
</tr>
<tr>
<td>610 [29]; 617.6; 619.2; 631.1; 632.2; 636.7; 647.1</td>
<td>[29], this work(^*)</td>
<td>(\nu) (Sn–O)</td>
</tr>
<tr>
<td>650 [28]; (665,667) [30]; 668.6; 680 [31];</td>
<td>[28]</td>
<td>(\nu) (Sn–O–Sn)</td>
</tr>
<tr>
<td>690 [28]; 690.5</td>
<td>[28], this work(^*)</td>
<td>(\nu) (Sn–O)</td>
</tr>
<tr>
<td>703.7; 728.9; 742.2; 757.1; (737; 770) [27]; 774.3</td>
<td>[27], this work(^*)</td>
<td>(\nu)(_{as}) (Sn–O–Sn)</td>
</tr>
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\(\nu\): terminal; B: bridged
Optical properties of SnO₂ were investigated in UV, VIS, and IR ranges. It was found that the optical bandgap lies between 3.58 and 3.72 eV and the IR transmission of SnO₂, n-type semiconductor, is sharply decreased by electron absorption and the quality of vibrational information concerning the surface species depends strongly on the nature of the treatment.

REFERENCES


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